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Appl. No. 10/669,671

JAN 2 4 2006

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No	10/669,671
Filing Date	September 23, 2003
Inventor	
Assignee	
Group Art Unit	2823
Examiner	
Attorney's Docket No	
Customer No.	
Title: Methods of Filling Gaps and Methods	
Plasma Chemical Vapor Deposition	

## **RESPONSE TO DECEMBER 13, 2005 FINAL OFFICE ACTION**

To:

Mail Stop AF

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

From:

Jennifer J. Taylor, Ph.D. (Tel. 509-624-4276; Fax 509-838-3424)

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## AMENDMENTS

## **Introductory Comments**

In reply to the Final Office Action of December 13, 2005, applicant amends and remarks as follows.

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